

<b>Notice of References Cited</b>	Application/Control No. 09/581,770	Applicant(s)/Patent Under Reexamination SAMPATH ET AL.	
	Examiner Ruixiang Li	Art Unit 1646	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,531,445 B1	03-2003	Cohen et al.	514/2
	C	US-6,498,142 B1	12-2002	Sampath et al.	514/12
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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